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LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT

2829

ATTY. DOCKET NO.: P68985US0 GROUP ART UNIT: ~~Not Yet Assigned~~
SERIAL NO.: New Application FILING DATE: July 14, 2003
APPLICANT(S): Sang-Don LEE TODAY'S DATE: July 14, 2003

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	INT'L CLASS	SUB- CLASS	FILING DATE (If Appropriate)
AA						
AB						

FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION (YES) (NO)
AC					
AD					
AE					

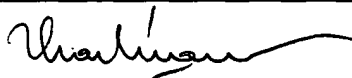
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

LF AF Udo SCHWALKE, et al.; "Dual-Workfunction Gate Engineering in a Corner Parasitics-Free Shallow-Trench-Isolation Complementary-Metal-Oxide-Semiconductor Technology"; Jpn. J. Appl. Phys. Vol. 38; 1999; pp.2232-2237.

AG

EXAMINER

DATE CONSIDERED



9/17/04

* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant(s).